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A Pulse-Biasing Small-Signal Measurement Technique Enabling 40 MHz Operation of Vertical Organic Transistors

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Organic/polymer transistors can enable the fabrication of large-area flexible circuits. However, these devices are inherently temperature sensitive due to the strong temperature dependence of charge carrier mobility, suffer from low thermal conductivity of plastic substrates, and are slow due to the low mobility and long channel length (L). Here we report a new, advanced characterization circuit that within around ten microseconds simultaneously applies an accurate large-signal pulse bias and a small-signal sinusoidal excitation to the transistor and measures many high-frequency parameters. This significantly reduces the self-heating and therefore provides data at a known junction temperature more accurate for fitting model parameters to the results, enables small-signal characterization over >10 times wider bias I - V range, with $\sim 10^5$ times less bias-stress effects. Fully thermally-evaporated vertical permeable-base transistors with physical $L = 200$ nm fabricated using C_{60} fullerene semiconductor are characterized. Intrinsic gain up to 35 dB, and record transit frequency (unity current-gain cutoff frequency, f_T) of 40 MHz at 8.6 V are achieved. Interestingly, no saturation in $f_T - I$ and transconductance ($g_m - I$) is observed at high currents. This paves the way for the integration of high-frequency functionalities into organic circuits, such as long-distance wireless communication and switching power converters.

Organic electronics is expected to provide a technology platform for emerging applications which require large-area mechanically-flexible light-weight circuits. For instance, organic light-emitting devices have been demonstrated on plastic substrate for flexible and unbreakable displays¹. Furthermore, organic devices can be made ultra-thin^{2,3}, stretchable⁴, and can conformally interface with the skin and moving internal organs such as uneven heart tissue⁵, making them suitable for health monitoring and artificial electronic skins⁶. The use of organic transistors has also been demonstrated for ferroelectric memories⁷ and sophisticated electrical circuits. E.g. using inductively-coupled coil antennas, organic RFID tags can be employed for short distance (2–5 cm) wireless communication⁸, or a fully-printed bendable audio system has been demonstrated⁹, consisting of a 128 cm² piezo-polymer loudspeaker and a self-biased organic audio amplifier.

While compact device modeling is a key requirement for complex circuit simulation and system design, accurate device characterization and parameter extraction is a prerequisite for fine tuning and optimization of model parameters. In this regard, the characterization and modeling of organic transistors is for two reasons particularly difficult: Firstly, there are unusual physical effects in organic transistors that cause serious difficulties when extracting static modeling parameters such as charge carrier mobility or gate-source capacitance. For example, when using conventional long-channel Field-Effect Transistor (FET) equations for calculating the charge carrier mobility, the presence of a kink in the transfer I - V characteristic can cause significant mobility overestimation^{10,11}; large contact or source/drain electrode resistances result in large mobility underestimation^{12,13}; or measuring the

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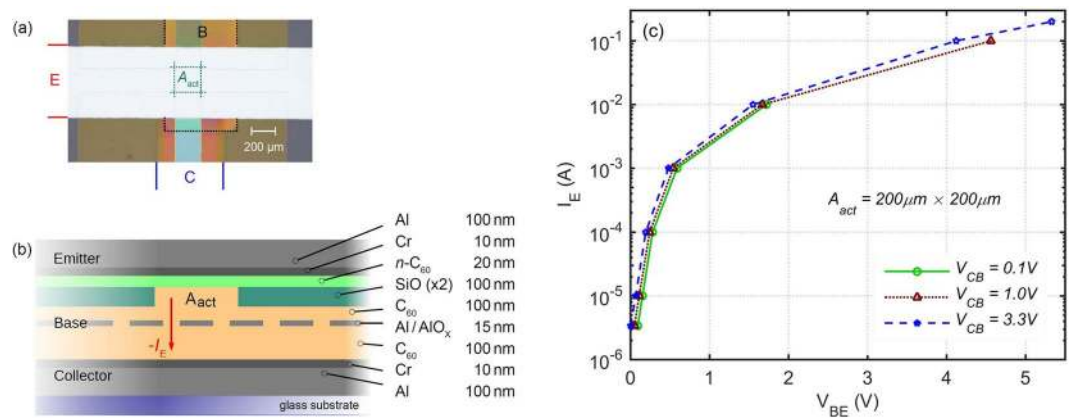


Figure 1. Organic permeable base transistor (OPBT). (a) Modified device photo showing the three electrodes and the active area from top view; dot lines are added around the base and A_{act} (b) Drawn device structure, side view in A_{act} . (c) Emitter current as a function of base-to-emitter voltage.

gate capacitance at high frequencies and using this value for extracting the mobility from DC, i.e. near 0 Hz, I–V measurements brings an additional error if there is a strong gate capacitance frequency dependence¹³.

Secondly, there are also time-dependent processes happening in organic transistors such as self-heating and bias-stress so that the dynamic behavior of organic FETs is insufficiently described by state-of-the-art DC parameter models.

Self-heating is an important physical effect which occurs during the device characterization at high DC $I \times V$ points and has two major drawbacks. First, it results in an unknown device junction temperature if the junction-to-substrate thermal resistance is not known, making the measured data unsuitable for fitting any compact models into it. Second, junction burning or breakdown limits the maximum I–V point at which the device can be characterized, whereas in some real circuits such as digital logic gates and super regenerative oscillators only a very high transient pulse current is passing through the device during the switching or on time.

Self-heating is an issue in all semiconductor-based devices, but organic transistors are inherently more sensitive to it because their charge carrier mobility strongly increases with temperature^{4,15}, and their source/drain metal electrode to polymer channel contact resistance rapidly decreases with it¹⁵. In addition, these devices are mostly intended for flexible plastic substrates, which are in general very poor thermal conductors resulting in large junction to substrate thermal resistance. This problem is partly alleviated by low current densities in organic devices. However, these devices generally work instead at relatively higher voltage levels, and the current density will increase by development of higher mobility organic semiconductors in the future.

Device measurement can be divided into two general domains of large-signal and small-signal measurements. For the large-signal I–V characterization, the self-heating can be suppressed by applying short pulses instead of long-time DC biasing¹⁴. This can be easily done using existing commercial equipment such as the Keysight Precision Source/Measure Unit B2912A. However, for the case of small-signal measurements this is absolutely not straightforward and has not been done so far. All existing small-signal measurement techniques work based on the principle of long-time DC biasing of the device at a known I–V point, and then superimposing a known small-signal voltage/current on this DC bias at one input terminal of the device, and measuring the output small-signal voltage/current at another terminal of the device. For example, this approach has been used in our previous works^{13,16} for measuring the transconductance (g_m), intrinsic gain (A_{v0}), gate/base impedance, and current gain (h_{21}); for S-parameter measurement¹⁷; and for transit frequency (f_T) measurement^{18–20}.

In this context, DC biasing of the device also has a third drawback. Most organic transistors still suffer from the bias-stress effect, which is due to the trapping of charge carriers, and causes dynamic shift of the threshold voltage as well as the electric field inside the device^{21,22}. Therefore, applying a DC bias during long-time measurements changes the characteristics of the device and reduces the accuracy and repeatability of the results.

In order to overcome the above-mentioned problems, we present in this paper for the first time an advanced pulse-biasing characterization circuit, which can turn on the organic transistor and apply an accurate bias I–V to it in less than ten microseconds, then apply a small sinusoidal signal to the device and measure several small-signal parameters such as h_{21} , f_T , g_m and A_{v0} , and then quickly turn off the device again. This approach significantly reduces the junction temperature increase, and allows measurements at much higher bias currents. In addition, the new setup can be used for measuring the temporal evolution of stress and self-heating effects over a μ s to ms time scale.

As a case study, we characterized the fully-thermally-evaporated n-type vertical Organic Permeable-Base Transistor (OPBT)²³, shown in Fig. 1. The OPBT is a promising low-voltage high-current high-speed device, fabricated solely using low-resolution low-cost shadow masks. This transistor resembles triodes and bipolar junction transistors, but here we have a thin metal base layer that contains naturally occurring pores. The native aluminum oxide of this electrode leads to a channel formation around it and the fact that the base potential controls the electrons flowing from emitter to collector. Space charge limited current (SCLC) in the undoped C_{60} fullerene layers is the main limitation of this transistor²⁴, whereas electron injection is very efficient due to the thin n-doped

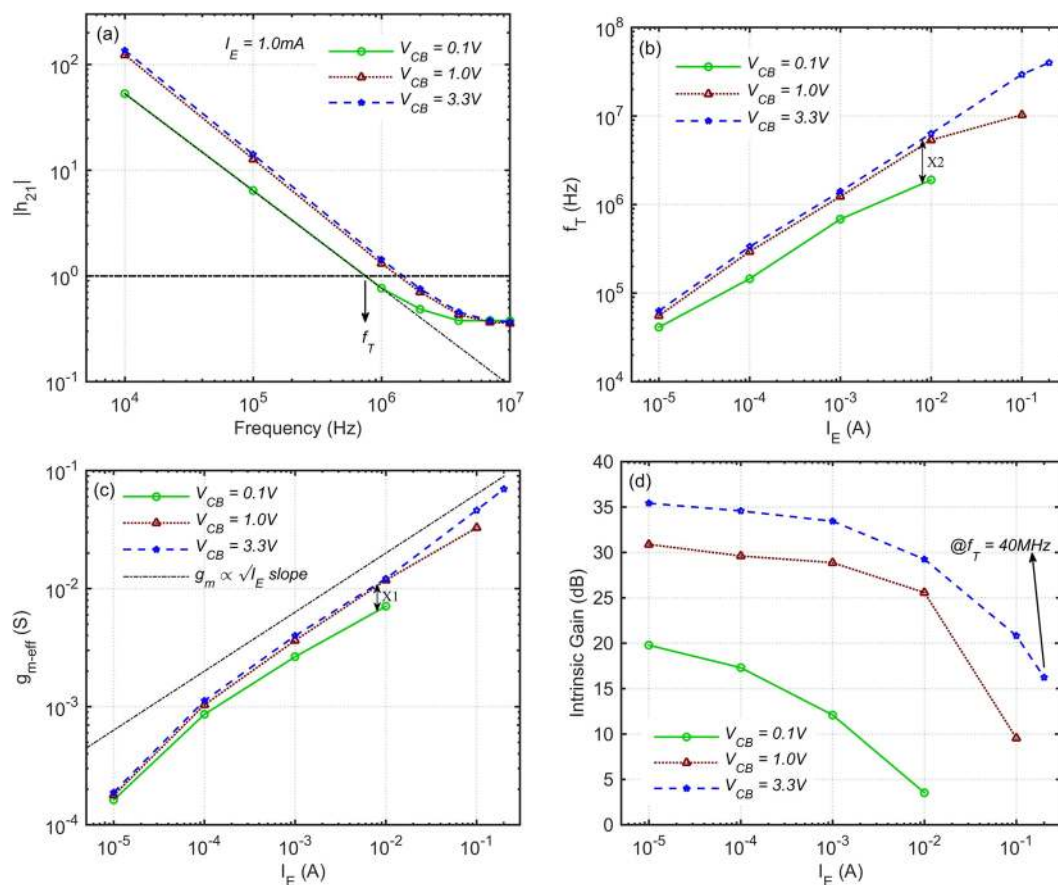


Figure 2. Measured small-signal performance of the OPBT with $A_{\text{act}} = 200 \mu\text{m} \times 200 \mu\text{m}$. (a) Current gain at 1 mA pulse bias versus frequency. (b) Transit frequency versus pulse-biased emitter current. (c) Transconductance versus pulse-biased emitter current. (d) Intrinsic voltage gain A_{v0} versus pulse-biased emitter current.

C_{60} layer. Details of the device fabrication and operation mechanism, DC I–V characteristics, SCLC and device simulation can be found in other publications^{23,24}, as well as the methods section.

This manuscript is organized in the following way. Firstly, we demonstrate the pulse-biasing measurement results of an OPBT device including the small-signal performance, and the temporal evolution of the charge distribution and self-heating effects occurring in the device. Secondly, we focus on the characterization circuit and small-signal parameter extraction techniques. Finally, we discuss the consequences of our findings on the context of real circuit applications.

Case Study Measurement Results

Measurements are performed at a controlled room temperature of $\sim 25^\circ\text{C}$, on the samples shown in Fig. 1, with an active area of $A_{\text{act}} = 200 \mu\text{m} \times 200 \mu\text{m}$, at three low/moderate/high collector-to-base voltages of $V_{\text{CB}} = 0.1 \text{ V}/1.0 \text{ V}/3.3 \text{ V}$, respectively.

Transfer large-signal pulse I–V characteristics of the OPBT are shown in Fig. 1(c), reaching a peak current of $I_{\text{E}} = 200 \text{ mA}$ at a total voltage of $V_{\text{CE}} = V_{\text{CB}} + V_{\text{BE}} = 8.6 \text{ V}$. This corresponds to a current density of $5 \mu\text{A}/\mu\text{m}^2$ in the A_{act} . At $V_{\text{CE}} = 1.0 \text{ V}$, the device can still drive $47 \text{ nA}/\mu\text{m}^2$.

Transit Frequency (f_{T}). The small-signal current gain (h_{21}) is defined as the ratio of the small-signal collector current (i_c) over the small-signal base current (i_b) measured when both emitter and collector are small-signal AC ground.

An example of the magnitude of h_{21} as a function of frequency at a pulse bias $I_{\text{E}} = 1.0 \text{ mA}$ at three different V_{CB} is shown in Fig. 2(a). The h_{21} is decreasing $\sim 20 \text{ dB}$ per decade (i.e. proportional to $1/f$) as known for conventional transistors. f_{T} is defined as the frequency at which the extrapolation from the low frequency part of h_{21} falls to unity. It is an important figure of merit of a transistor, indicating the frequency range in which the device can amplify the input current signal.

Measured f_{T} versus pulse bias emitter current is shown in Fig. 2(b), reaching $f_{\text{T}} = 40 \text{ MHz}$ at pulse $I_{\text{E}} = 200 \text{ mA}$; i.e. current density of $5 \mu\text{A}/\mu\text{m}^2$; at $V_{\text{CB}} = 3.3 \text{ V}$, $V_{\text{BE}} = 5.3 \text{ V}$ and $V_{\text{CE}} = 8.6 \text{ V}$; measured at the shortest possible pulse duration of $\sim 10 \mu\text{s}$. To the best of our knowledge, this is the highest measured f_{T} for an organic transistor so far. As a comparison, $f_{\text{T}} = 27.7 \text{ MHz}$ at around three times higher voltage of $V_{\text{DS}} = 25 \text{ V}$ for C_{60} , and 11.4 MHz

for Pentacene at 25 V were previously reported for planar transistors on glass substrate¹⁹, fabricated using high-resolution patterning techniques such as photolithography and lift-off process. $f_T = 20$ MHz at 30 V was achieved using laser sintering of high resolution electrodes on glass¹⁸. In vertical structures, $f_T = 1.5$ MHz was reported for step edge devices²⁵, and $f_T = 20$ MHz at 15 V for a 3D transistor structure²⁰.

Transconductance (g_m). The effective transconductance versus pulse bias current is shown in Fig. 2(c) and is calculated as the ratio of the i_c to the small-signal base-emitter voltage; measured below the frequency of $f_T/10$. Interestingly, no saturation of the $g_{m\text{-eff}}$ at high current densities is observed. This indicates that the parasitic emitter resistance R_E is small, otherwise $g_{m\text{-eff}} = g_m/(1 + g_m \times R_E)$ would eventually saturate to $1/R_E$ at high currents. The small R_E means that the electrode resistance is small and the n- C_{60} doped layer is making low impedance interfaces to both Cr and intrinsic- C_{60} layers.

Considering the equation $f_T \approx g_m/(2\pi \times (C_{be} + C_{bc}))$, increasing the V_{CB} bias from 0.1 V to 3.3 V at fixed I_E in Fig. 2(c) improves the transconductance, however, the amount of the corresponding f_T or h_{21} improvement at the same I_E in Fig. 2(b or a) is always higher, e.g. X2 is 89% more than X1. This is because of the fact that increasing the V_{CB} depletes the collector-base C_{60} layer from the charge carriers, and this also reduces the C_{bc} and therefore further improves the f_T .

Intrinsic Gain (A_{v0}). Intrinsic gain is the maximum small-signal voltage gain that a device can provide, and is equal to $g_m \times r_{out}$, where $r_{out} = \partial V_{CE}/\partial I_C$ is the output resistance of the device. Basically a transistor with A_{v0} less than one, i.e. 0 dB, is a useless device, because it cannot perform any amplification.

In general, A_{v0} decreases with scaling down the channel length. However, as shown in Fig. 2(d), OPBT can provide a good gain of 35 dB at low currents and a fairly acceptable gain of 16 dB at the $f_T = 40$ MHz bias point, i.e. $I_E = 200$ mA, with a short physical $L = 200$ nm. With $A_{v0} = 16$ dB, one can make an amplifier with a gain of 10 dB per stage by means of the bootstrapping technique¹⁶.

A diffusion-driven organic transistor was recently reported²⁶, which can even provide 57 dB of intrinsic gain at $W/L = 100 \mu\text{m}/12.5 \mu\text{m}$. However, this transistor can drive less than 200 nA at tens of volt, and therefore is only suitable for very low-current low-speed applications.

Temporal Evolution of Charge Distribution, Self-Heating and Bias-Stress. The charge carrier mobility in organic semiconductors is known to improve with temperature. In addition, polymeric materials as used for plastic substrates are generally weak thermal conductors. For these reasons, gradual self-heating of organic devices at high $I \times V$ points has a large impact on the device characteristics.

As will be explained in the next section, the developed pulse-biasing setup can also accurately monitor the variations of V_{BE} , i.e. ΔV_{BE} after applying a fixed I_E to the device. Measuring the temporal evolution of this ΔV_{BE} allows to study the effect of self-heating with the highest sensitivity, because in case of self-heating, this ΔV_{BE} would be proportional to the increase of the device temperature, i.e. ΔT , and therefore to the power dissipated in the device. This fact is because organic semiconductors have usually strongly increasing mobility with temperature^{14,15}. Further, the contact resistance strongly decreases simultaneously¹⁵, resulting in a lower required V_{BE} , i.e. negative ΔV_{BE} , at fixed I_E . This ΔV_{BE} would be linearly proportional to ΔT when ΔT is small, but in general it is a nonlinear function.

For the purposes of comparison and verification of this method, ΔV_{BE} of a general purpose, silicon Bipolar Junction Transistor (BJT) is measured at two different $I_E \times V_{CE}$ products of 100 mW and 200 mW, and is shown in Fig. 3(a). Conventional BJT is also a vertical device, but the silicon substrate conducts heat around 10 times better than the glass. In this experiment, tracking of the V_{BE} variation is started 90 μs after turning on the device. The V_{BE} variation during the initial 90 μs was smaller than the accuracy of the measurement setup. 200 mW is applied one time by doubling the current and one time by doubling the voltage. As expected, in both cases ΔV_{BE} is nearly two times that of the 100 mW. This confirms that here we only have self-heating, but no stress effects.

Similar experiments are performed on the OPBT at two low and high current levels as shown in Fig. 3(b and c). The V_{BE} and V_{CE} given in this figure are average values over the measurement time. In Fig. 3(b), although we have a considerable amount of ΔV_{BE} at $1 \text{ mA} \times 1.6 \text{ V}$, surprisingly, doubling the V_{CE} does not affect the ΔV_{BE} , whereas doubling the current increases it by $\sim 60\%$. This proves that in this case the observed effect is not self-heating.

As shown in Fig. 1(a), although the emitter window is $200 \mu\text{m} \times 200 \mu\text{m}$, the underneath base and collector electrodes are wider. Therefore we speculate that this effect is induced by the lateral diffusion of some of the electrons accumulated around the base oxide towards the outside of this window. This diffusion gradually increases the effective active area of the channel, and therefore decreases the required V_{BE} at the fixed $I_E = 1 \text{ mA}$ by the amount of $\sim 9\%$ after 200 ms in Fig. 3(b). Increasing the collector voltage has a small impact on the charge in the C_{60} layer of the emitter side, whereas increasing the I_E largely affects this charge density and the required V_{BE} .

At a 15 times higher $I_E \times V_{CE}$ shown in Fig. 3(c), doubling the current increases the $\Delta V_{BE} \sim 95\%$, but here doubling the voltage also increases it $\sim 66\%$. This indicates that in this case in addition to the lateral diffusion of the charge carriers, self-heating is also occurring and is important. Since self-heating has a considerable impact after hundreds of μs at 10 mA, obviously at 100 mA range it would already have an impact after tens of μs . In order to circumvent this effect, the pulse-biasing circuit developed here can turn on and apply an accurate bias to the device under test within few μs , and immediately start doing small-signal analysis afterwards.

Figure 3(d) shows a long-time DC stress measurement, performed using the Keysight B2912A Precision SMU, at a very low current of 100 μA at which self-heating would be negligible. The ΔV_{BE} tracking is started ~ 200 ms after turning on the device. Here, we clearly see different mechanisms occurring in different directions. The ΔV_{BE} initially goes negative due to the lateral charge diffusion, but finally starts increasing due to the bias-stress effect. Surprisingly, the lateral charge diffusion seems to be the dominant effect for an incredibly long time of ~ 1000 s. This might really be the case, because far away from the A_{act} there is no lateral electric field, and the undoped C_{60}

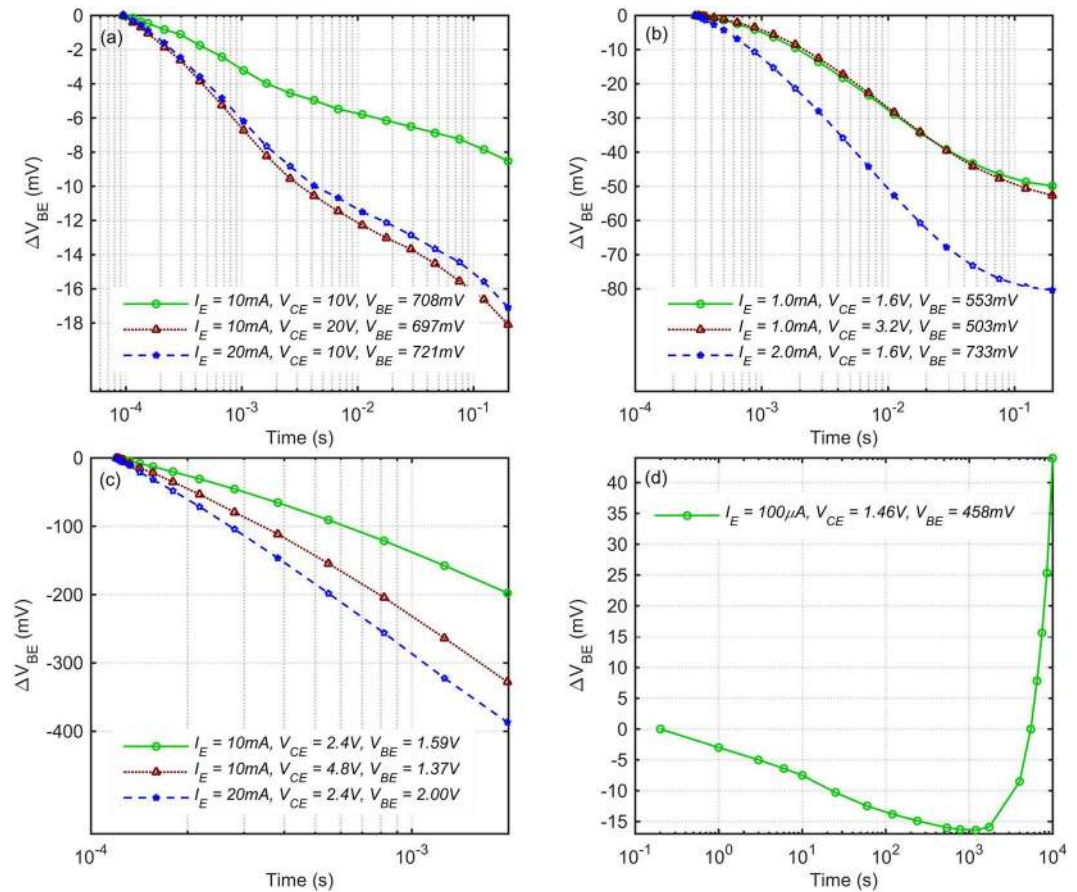


Figure 3. V_{BE} change due to self-heating, lateral diffusion of charge carriers and bias-stress. (a) Self-heating in a standard silicon bipolar junction transistor, 2N3904. (b) The OPBT at low-current, only showing lateral diffusion of charge carriers. (c) The OPBT at high-current, showing both self-heating and lateral diffusion of charge carriers. (d) Long-time bias-stress in the OPBT.

layer could be extremely resistive causing very slow diffusion of electrons. However, other unknown mechanisms might also be the reason, such as very slow changes in the morphology of C_{60} or base-oxide under the electric field. We cannot provide a concrete explanation for the observed behavior. Anyway, it is a very slow and small effect in the mV range.

Pulse-Biasing Small-Signal Characterization Circuit

Figure 4 shows the simplified schematic of the new measurement setup. Examples of the waveforms are illustrated in Fig. 5. An accurate 1 V reference is generated using the LT1004 voltage reference, and is used for defining the pulse I_E passing through $R_{E1} = 1 V/I_E$ as shown in Fig. 5(b). DC voltage at the base electrode is zero. ME3 forces $V_E = 0 V$ when there is no V_G pulse, keeping the OPBT off. The 10 V low-duty-cycle gating pulse V_G turns on ME2 on its rising edge to start the pulse bias current I_E , and turns off ME3. The small-signal excitation comes from the sinusoidal source $2 \times V_{in^*}$, while C_{E1} and C_{C2} keep both emitter and collector at small-signal AC ground. Applying and stabilizing of the bias point at different nodes is done over the time interval of 0 to $\sim 6 \mu s$. Circuit parameters such as V_{D1} , V_{E1} and R_{C1} are manually tuned to minimize this initialization time. The small-signal measurements are carried out afterwards.

At the base side, we have $R_{B4} \gg R_{B1} \gg 50 \Omega$, and the input base impedance $|Z_b| \approx 1/C_b \omega \ll R_{B1}$ at the measurement frequency. The diode D_{B1} has less than 0.3 pF parasitic capacitance and is completely off during the small-signal measurement time.

h_{21} and g_m Measurement Circuitry. The small-signal sinusoidal excitation comes from a differential signal generator. The invert of V_{in} arrives at the oscilloscope, and then V_{in} is calculated from it. The Cables 1–4 are 50 Ω , i.e. V_{in} and V_{inB} are slightly delayed versions of V_{in^*} . Since $R_{B1} \gg 50 \Omega$ we have $|V_{inB}| \approx |V_{in^*}| = |V_{in}|$. $i_c/i_b/i_e$ are small-signal currents into the collector/base/emitter, respectively. As long as $R_{B1} > 7/C_b \omega$, $|i_b|$ can be estimated as $|V_{in}|/R_{B1}$ with less than 1% error. However, by measuring the signal amplitude at V_B using a high-impedance probe, as shown in Fig. 5(g), we can calculate the input base capacitance C_b and then calculate $|i_b|$ even more precisely.

At the collector side, the large-bandwidth op-amp O_1 forces $n3$ to be ground and the large coupling capacitor C_{C2} keeps the collector to be AC ground. L_{C1} provides a path for the pulse I_E bias current, and $L_{C1} \omega \gg 1/C_{C2} \omega$,

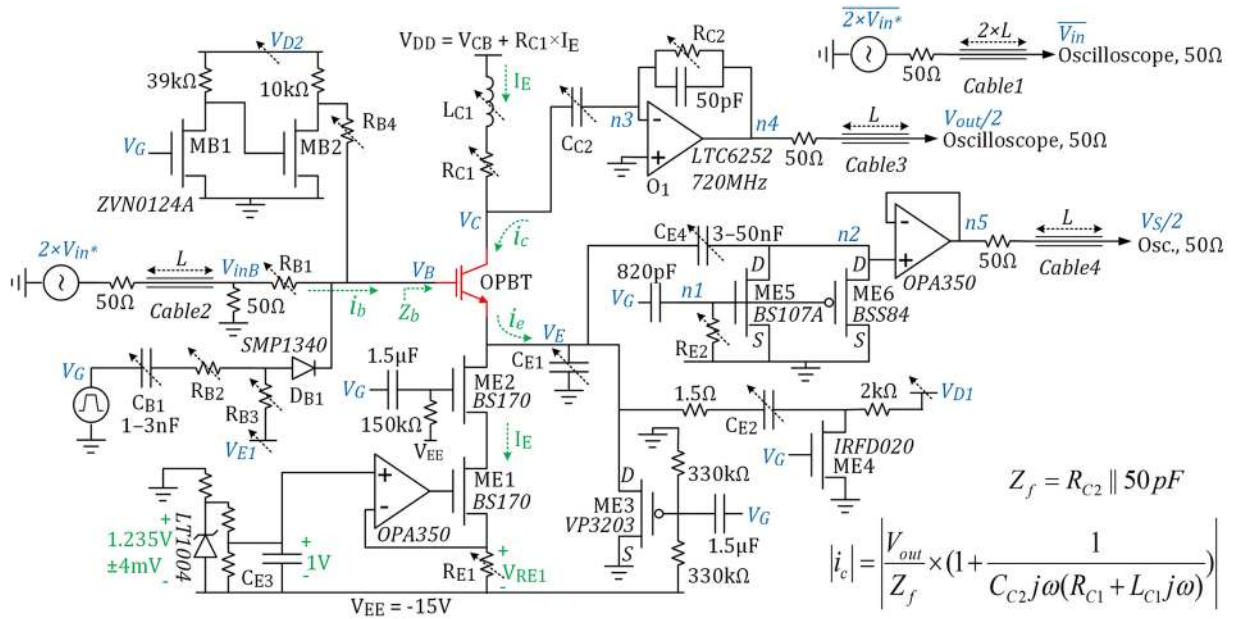


Figure 4. Simplified schematic of the new pulse-biasing small-signal measurement setup.

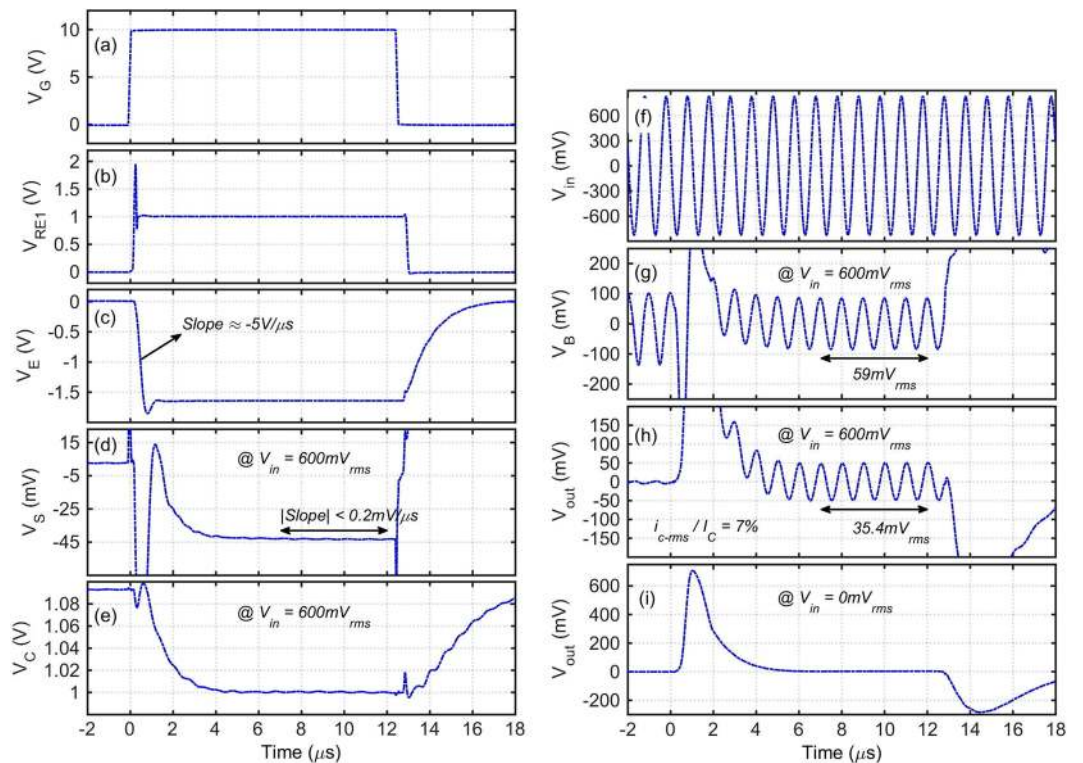


Figure 5. Signal waveforms of the characterization setup at pulse $I_E = 10 \text{ mA}$ and bias $V_{CB} = 1 \text{ V}$, $R_{E1} = 100 \text{ }\Omega$, $C_{E1} = 0.35 \text{ }\mu\text{F}$, $C_{E2} = 0.1 \text{ }\mu\text{F}$, $C_{C2} = 0.22 \text{ }\mu\text{F}$, $L_{C1} = 5 \text{ }\mu\text{H}$, $R_{C2} = 50 \text{ }\Omega$, $R_{B1} = 4.7 \text{ k}\Omega$, $R_{B4} = 1 \text{ M}\Omega$ and frequency = 1 MHz . (a–h) Signals are measured concurrently at $V_{in} = 600 \text{ mV}_{rms}$. (i) V_{out} is measured at $V_{in} = 0 \text{ V}_{rms}$.

i.e. most of the i_c passes through C_{C2} , but C_{C2} is so large that the small-signal voltage amplitude at the collector is much smaller than the signal at the base. It is possible to calculate the exact value of $|i_c|$ using the equation given in Fig. 4. Since I_E is a pulse, it is important to make sure that $L_{C1}-C_{C2}$ do not cause additional ringing on the V_{out} . This is assured by tuning $R_{C1} \approx 2 \times \text{sqrt}(L_{C1}/C_{C2})$. As shown in Fig. 5(i), when I_E pulse is applied but V_{in} is zero, no ringing appears on the V_{out} after Time = $6 \text{ }\mu\text{s}$. A 50 pF capacitor is added to the feedback loop around O_1 to improve the stability.

Cable1 is intentionally twice the length of Cables 2 and 3; so that the signal delay from V_{in*} to V_{inB} plus the signal delay from n4 at the output of the op-amp O1 to V_{out} would be equal to the delay along Cable1. In this way, we could also measure the phase of h_{21} by measuring the phase difference between V_{in} and V_{out} on the oscilloscope. However, only the magnitude of h_{21} is needed to extract the f_T , and $|h_{21}| = |i_c|/|i_b|$.

At the emitter side, a very large C_{E1} , in the μF range, is needed to keep the emitter at AC ground during the small-signal measurement after $T_{in} = 6 \mu s$. On the other hand, a time much larger than $T_0 = V_{BE} \times C_{E1}/I_E$ would be needed for V_E to reach its required value; with the parameter values given in Fig. 5, this would be $T_0 = 57 \mu s$. In order to significantly speed up this initialization time, the power switch ME4 is added. During the long off time, i.e. $V_G = 0 V$, C_{E2} is charged to a tunable voltage V_{D1} in the range of 0–30 V, and then on the rising edge of V_G , a very large transient current up to $V_{D1}/1.5 \Omega$ is sunk through C_{E2} and as shown in Fig. 5(c) this current quickly charges C_{E1} to a V_{BE} that enables an OPBT current exactly equal to the I_E . However, this is true only if after this initialization time, no part of the I_E passes through $C_{E1,2,4}$. In other words, the gradual slope of V_E should become zero.

To accurately monitor the gradual slope and variations of V_E after its sharp falling edge, V_G turns on ME5 for the first 1–3 μs , and during this time the small capacitor C_{E4} is charged to the initial emitter voltage. Then the $k\Omega$ resistor R_{E2} quickly pulls n1 to 0 V, turning off ME5, resulting in a $>4 G\Omega$ resistance across ME5,6. Because of the large time constant of $C_{E4} \times R_{DS-ME5,6}$, any further mV variations at V_E will be directly tracked at n2 and V_S . V_{D1} is manually tuned to have $\sim 0 mV/\mu s$ gradual slope at V_S over the small-signal measurement interval. Comparing Fig. 5(c to d), the V_S circuitry is providing $\sim 25X$ zoom on the V_E for accurate tuning of V_{D1} . ME6 just forces n2 to ground on the falling edge of V_G .

On the falling edge of V_E , a large $R_{B1} \times C_b$ time constant can slow down the charging of the base-emitter capacitance and increase the required initialization time. To make this faster, on the rising edge of V_G , a certain amount of charge is injected into the base through $C_{B1}-R_{B2}-D_{B1}$. V_{E1} is a negative DC voltage that controls the amount of this charge, and turns off the D_{B1} afterwards. V_{E1} is manually tuned to keep V_B around 0 V.

DC leakage current into the base, I_B , is usually negligible. However, in case of a large I_B , R_{B4} can be added, and V_{D2} controls the DC current injected into the base.

Intrinsic Gain Measurement Method. For measuring the intrinsic gain, V_E is accurately measured at two slightly different collector voltages, but with equal pulse I_E . Then we would have $g_m \times \Delta V_{BE} = \Delta V_{CE}/r_{out}$. Therefore $A_{v0} = g_m \times r_{out} = \Delta V_{CE}/\Delta V_{BE}$ is obtained. For this measurement V_B is grounded, $C_{E1,2}$ are not needed, and V_C is shorted to V_{DD} .

Measurement Limits. The low-leakage BS170 MOSFET used as ME1,2 current source can drive up to $\sim 300 mA$ into the OPBT. Larger MOSFETs with higher current drive capabilities, and accurate resistors down to 100 $m\Omega$ range for R_{E1} are widely available in the market. Therefore, accurate I_E pulses up to 10 A should be feasible with the proposed circuit, but it was not needed in our case study. At $I_E < 1 \mu A$ range, the gate leakage through ME1,2 can cause bias inaccuracies; therefore ultra-low leakage MOSFETs would be needed for this case. The maximum bias voltages V_{CB} and V_{BE} are basically controlled by the V_{DD} and V_{E5} ; there is no specific limit in this regard.

The shortest measurement pulse width is mainly limited by the required initialization time for reaching the steady state ($\sim 6 \mu s$ in Fig. 5); afterwards, the small-signal information can be extracted in principle even from one sinusoidal signal cycle. As can be seen in Fig. 5(b), the I_E pulse settles in less than 2 μs . The charge injector circuitry ME4- C_{E2} has a very short R-C time constant of $< 160 ns$. However, the OPBT capacitances and the frequency of the sinusoidal signal impose the main limitations on the initialization time. Although the charge injector path $C_{B1}-R_{B2}-D_{B1}$ significantly speeds up the charging of the base capacitance C_b , as can be seen in Fig. 5(g), still some time ($\sim 3 \mu s$) proportional to $R_{B1} \times C_b$ is needed for the V_B to reach the steady state after D_{B1} turns off. On the collector side, C_{C2} should be more than 20×20 times larger than C_b to keep the small-signal voltage at V_C twenty times smaller than V_B at the frequency where $|h_{21}| = 20$ is measured. We recommend $L_{C1}C_{C2}\omega^2 > 10$ so that the inaccuracy of the L-C components does not make large error in the i_c equation in Fig. 4. Taking all these points into account, practically we found that by optimizing the circuit parameters, the initialization time can be minimized to 5–7 periods of the sinusoidal signal.

Further Discussions and Conclusion

The proposed pulse-biasing small-signal measurement circuit enables analog characterization of the device over > 10 times wider I–V range comparing to the simple DC biasing approach^{13,23}, and provides a much better control on the junction temperature by adjusting the pulse duration. It can also precisely track the ΔV_{BE} at different power densities for better understanding of the self-heating effects.

For the $\sim 12 \mu s$ measurement shown in Fig. 5, if we repeat the pulse every 1.2 s, the waveforms can still be well monitored on the oscilloscope, while the bias-stress rate in the device decreases by a factor of $\sim 10^5$ comparing to the DC biasing method. Therefore, many more measurements can be performed on the same fresh device during several days, providing reliable data for device modeling.

The OPBT currently suffers from a low charge carrier mobility in the vertical direction $\sim 0.06 cm^2/V.s$ ²³. However, the study presented in this work proved that despite this very low mobility, it can already reach the record f_T of 40 MHz and the intrinsic gain of 35 dB at $V_{CE} = 8.6 V$ thanks to the short channel length. There is certainly a large room for further improvement of this speed by developing organic semiconductors which can provide higher mobility in the vertical direction. This can be better understood by considering the fact that in FETs, above the threshold region g_m and therefore f_T are proportional to $\sqrt{\mu \times I_E}$. This $g_m - I_E$ trend can be seen in Fig. 2(c), and more importantly, no g_m or f_T saturation is observed at high currents, confirming the room for reaching higher speeds. A higher mobility will also result in a lower bias voltage, power and self-heating for reaching the same I_E . In planar organic FETs, mobility in the range of 3–30 $cm^2V^{-1}s^{-1}$ has been reported by several groups^{12,27–29}. Device simulations also predict sub-nano-second intrinsic switching delay for OPBTs with a mobility of 10 $cm^2/V.s$ ³⁰.

A $f_T \geq 40$ MHz can pave the way for integrating new functionalities into organic circuits and systems. Long-distance wireless communication is the first example, because in this case the key challenge is the extremely large size of the antenna required to have electromagnetic wave radiation in MHz regime. For example, an electrically-small single-turn loop antenna has a radiation resistance, and therefore efficiency, roughly proportional to $\text{frequency}^4 \times D^4$, where D is the diameter of the loop; an antenna with $D = 1$ m radiates with an efficiency of 18% at 10.1 MHz³¹. Therefore, we can expect ~7% RF power radiation at 40 MHz with $D = 20$ cm which is a reasonable size for integration onto human body or cloth, or toys. Wireless communication can also be done in pulse mode. For example, super regenerative receivers, which are in use since 1940s³², turn on an oscillator just for a few μs , receive the data, and then turn it off again for a long time, similar to how we operated the device in this work.

As the second example, inductor-based switching power converters can be mentioned. Power supply is an essential part of any electronic system, and inductor-based switching power converters are the most energy efficient circuits widely used in up/down DC–DC converters and battery chargers. Key elements of such circuits are FET switches, diodes, inductors and capacitors. A typical switching circuit working with $<1 \mu\text{s}$ pulses would require spiral inductors in the $10 \mu\text{H}$ range which can be easily fabricated by inkjet printing or evaporating a single metal layer on a plastic substrate with outer diameter <10 cm. Organic rectifying diodes already can work at tens of MHz^{33,34}. Printed flexible $10 \mu\text{F}$ range multi-layer capacitors for power conversion applications have been demonstrated³⁵ and show a high relative dielectric constant of 15–22 up to 10 MHz. In addition to the high f_T , the high current drive capability of the OPBT is also an advantage for compatibility with this application. In this context, it also worth to mention that flexible batteries and organic solar cells are also already developed and even commercialized.

The pulse measurement results are also relevant for digital logic circuits in which we only have transient currents in the transistors.

Methods

The OPBT presented here is built in a single chamber UHV-tool. The glass substrate is previously cleaned with N-Methylpyrrolidone, distilled water, ethanol, and an Ultra Violet Ozone Cleaning System. By using thermal vapor deposition at high vacuum conditions ($p < 10^{-7}$ mbar), the OPBT stack layers are deposited through laser-cut, stainless steel shadow masks. The layer stacks, evaporation rates, and treatments are: Al 100 nm (1.0 Å/s); Cr 10 nm (0.1 Å/s); i-C₆₀ 100 nm (1.0 Å/s); Al 15 nm (1 Å/s); 15 min oxidation at air; i-C₆₀ 100 nm; 2 times (perpendicular to each other) SiO 100 nm with a free stripe of 200 μm (1.0 Å/s); n-C₆₀ 20 nm (0.4 Å/s) co-evaporating C₆₀ with W₂(hpp)₄ (purchased from Novald GmbH, Dresden) with 1 wt%; Cr 10 nm (0.1 Å/s); Al 100 nm (1.0 Å/s); encapsulation in a nitrogen atmosphere using UV cured epoxy glue without UV exposure on the active area; annealing for 2 h at 150 °C in a nitrogen glove-box on a heat plate, for positively affecting both current-transmission through the base and regeneration of the air-exposed C₆₀^{36,37}.

The 50 pF capacitor across the op-amp O₁ is a mica capacitor, but other capacitors in the circuit are polypropylene or polyester film capacitors. For C_{E1,2,4} polypropylene is preferred.

Figure 1(a) has been taken using the Nikon microscope ECLIPSE LV 100 ND. Dot lines are added around the base electrode and the active area. This photo is not recolored; base and collector look colorful because of the materials deposited on top of them; emitter electrode looks white because it is on the top.

Data availability. All data generated or analysed during this study are included in this published article.

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Author Contributions

B.K.B. designed and fabricated the characterization circuit, performed the measurements, and wrote the manuscript with the help of M.P.K., A.F., and H.K.; M.P.K. designed the transistor. A.F. and H.K. contributed to the analysis and interpretation of the measured data. K.L. and F.E. motivated and supervised the work. All authors reviewed the manuscript. The OPBT samples were fabricated at the IAPP and measured at the CCN.

Additional Information

Competing Interests: The authors declare no competing interests.

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